Scanning electrochemical microscopy (SECM) as a new approach for measuring photomineralization kinetics at an illuminated titanium dioxide film

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Scanning electrochemical microscopy (SECM) technique has been developed as a new approach to investigate the kinetics of interfacial photo electrochemical processes at the microscopic level. This system employed a finely polished and smooth quartz fiber of 250 μ m diameter, which guides the light flux to sensitize a thin film of TiO₂ (deposited on to the polished fiber surface from a 13.0 % colloidal slurry of TiO₂) by back-illumination. This initiates the local photo electrochemical process. The SECM probe (either a potentiometric or an amperometric micro disc UMEs of 25 μ m diameter) was positioned with high precision in close proximity to the TiO₂ surface to monitor the reactants or products of the ongoing photo degradation process.

The initial emphasis of this newly developed technique covered investigations in a very localized region during the TiO₂-sensitised photomineralisation of 4-chlorophenol (4 -CP) and the photo electrochemical reduction of O₂ in different substrate solutions, utilizing both potentiometric and amperometric approaches respectively. These photo electrochemical reactions were investigated at the tip electrode by measuring the time-dependent response after suddenly stepping the light flux.

Semiconductors are activated by absorbing a photon of ultra band gap energy which causes the transfer of an electron from the valence band (VB) to the conduction band (CB). A hole, h^+ , is formed in the VB. These photogenerated holes oxidize H₂O (or OH⁻) to form OH[•] which initiates the photomineralization process at the surface of the catalyst, while photogenerated electrons are captured by O₂ to produce superoxide anoin, which also oxidizes the organic pollutant.^{1,2,3} The net process for the complete oxidative mineralisation of 4-CP by semiconductor photosensitizers is given by the following reaction [1]:

4 -CP +6.5O₂
$$\xrightarrow[hv \ge E_{bg}]{\text{beg}}$$
 6CO₂ + 2H₂O + HCl [1]

The degradation pattern of 4-CP was monitored at the Ag/AgCl detector electrode in terms of Cl⁻ production and the kinetics of the photomineralization process was assessed through model studies using the well-defined properties of the SECM.^{4,5} A typical SECM image of Cl⁻ distribution at the illuminated TiO₂ surface is shown in Figure 1.

A significant depletion in $[O_2]$ was evident at the TiO₂ surface as a result of illumination, indicating that dissolved O_2 plays a key role in controlling the photodegradation process even at the microscopic level. A typical transient response recorded during the photoelectrochemical reduction of O_2 at the amperometric tip electrode is depicted in Figure 2.



Figure 1 Potentiometric image of the Cl⁻ distribution formed at the TiO_2 / aqueous interface during the photomineralization of 4-CP



Figure 2 Phototransient response at the tip UME for the reduction of O_2 detected at a tip/substrate distance of 8.50 μ m

References

 S. Ahmed, C. E. Jones, T. J. Kemp and P. R. Unwin, Phys. Chem. Chem. Phys. (PCCP), 1, 5229, (1999).
A. Mills and S. Le Hunte, J. Photochem. Photobiol. A: Chem., 108, 1, (1997).

3. H. D. Burrows, L. S.Ernestova, T. J. Kemp, Yu. I. Skurlatov, A. P. Purmal and A. N. Yermakov, Prog. React. Kinet., **23**, 145, (1998).

4. P. R. Unwin, J. Chem. Soc., Faraday Trans., **94**, 3183, (1998).

5. A. L. Barker, M. Gonsalves, J. V. Macpherson, C. J. Slevin and P. R. Unwin, Anal. Chim. Acta,, **385**, 223, (1999).

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